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PTO/SB/21 (08-00)

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TRANSMITTAL FORM <i>(to be used for all correspondence after initial filing)</i>	Application Number	09/885,609	
	Filing Date	Jun 20, 2001	
	First Named Inventor	Mak, Alfred W.	
	Group Art Unit	2812	
	Examiner Name	Unassigned	
Total Number of Pages in This Submission		Attorney Docket Number	5351/AMI-00-12

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Firm or Individual name	Law Office of Kenneth C. Brooks
Signature	<i>Kenneth C. Brooks</i>
Date	November 8, 2001

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Mak et al.

Serial No: 09/885,609

Filed: June 20, 2001

For: SYSTEM AND METHOD TO FORM A COMPOSITE FILM STACK
UTILIZING SEQUENTIAL DEPOSITION TECHNIQUES

PATENT APPLICATION

Group Art Unit: 2812

Examiner: unassigned

Supplemental Information Disclosure Statement

Hon. Commissioner
for Patents
Washington, D.C. 20231

Sir:

The following information is submitted in compliance with Applicants' duty of disclosure under 37 C.F.R. § 1.56. A copy of each reference recited below accompanies this document. Also enclosed are two (2) sheets of PTO form 1449 listing these references.

PATENT DOCUMENT

Patent Number

5,580,380

Inventor

Liu et al.

Grant Date

03-Dec-96

PCT DOCUMENT

Publication No.

WO 98/51838

Inventor

Rajagopalan et al.

Publication Date

19-Nov-98



NON-PATENT DOCUMENT

Kitagawa et al. Hydrogen-Mediated Low-Temperature Epitaxy of Si in Plasma-Enhanced Chemical Vapor Deposition, Applied Surface Science, pp. 30-4 (2000).

CERTIFICATE OF MAILING

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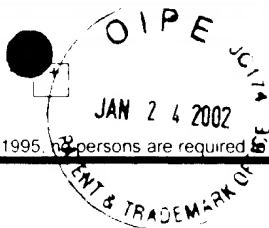
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Substitute for form 1449A/PTO

INFORMATION DISCLOSURE STATEMENT BY APPLICANT

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Sheet

1

of

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Complete if Known

Application Number	09/885,609
Filing Date	06/20/2001
First Named Inventor	Mak et al.
Group Art Unit	2812
Examiner Name	unassigned
Attorney Docket Number	5351/AMI-00-12

U.S. PATENT DOCUMENTS

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FOREIGN PATENT DOCUMENTS

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2

Application Number

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First Named Inventor

Mak et al.

Group Art Unit

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Examiner Name

unassigned

Attorney Docket Number

5351/AMI-00-12

Examiner
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Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.

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Kitagawa et al. Hydrogen-mediated low-temperature epitaxy of Si in plasma-enhanced chemical vapor deposition. Applied Surface Science, pp. 30-4 (2000).

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Signature

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